



PATENT
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RAFFAELE ZAMBRANO)
Serial No.: 09/191,743)
Filed: November 13, 1998)
For: IN-SITU DEPOSITION AND)
DOPING PROCESS FOR POLY-)
CRYSTALLINE SILICON LAYERS)
AND THE RESULTING DEVICE)

Group Art Unit: 2823

Examiner: M. Estrada

#13/EXT
10/25/01
V. Vannell
TECHNOLOGY COLLEGE
RECEIVED

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents
Washington, D.C. 20231


Sir:

In accordance with Rule 1.136, Applicant respectfully petitions the Commissioner for an extension of time extending to October 11, 2001, the period for response to the Office Action dated April 11, 2001. Please charge the amount of \$920.00 for the extension fee to Deposit Account No. 50-1556. The responsive paper is attached.

If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

Respectfully submitted,

Date: October 11, 2001

By: 
Stephen Bongini
Registration No. 40,917

FLEIT, KAIN, GIBBONS,
GUTMAN & BONGINI P.L.

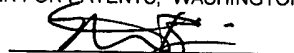
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D. C. 20231


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10/11/01
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